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Sub	Substitute for form 1449A/B/PTO			Complete if Known		
•				Application Number	10/646,607-Conf. #2264	
IN	IFORMATIC	ON DI	SCLOSURE	Filing Date	August 21, 2003	
S	STATEMENT BY APPLICANT			First Named Inventor	Lingyi A. Zheng	
_		•		Art Unit	1763	
(Use as many sheets as necessary)		Examiner Name	Ram N. Kackar Kakech Dhungi			
Sheet	neet 1 of 13		13	Attorney Docket Number	108298717US	

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"				O 7 11 1 1	Art	Unit	1763		
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